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Contents

OPTICAL MANUFACTURING I

11487 03	Fabrication of a 500 mm extreme freeform conformal window [11487-2]
11487 04	Observation of pressure distribution between tool and surface in different polishing situations [11487-3]
11487 05	The results of Goodman Technologies NASA Phase II SBIRs for additive manufacturing of mirrors and telescopes [11487-4]
11487 07	Octopus: a simple and effective tool for polishing slurry monitoring [11487-6]
	OPTICAL TESTING AND MODELING
11487 09	Error sources, compensation, and probe path optimization for on-machine metrology of freeform optics [11487-7]
11487 0A	Isotropic grating coupler for 3D silicon photonic architectures [11487-8]
11487 OB	A method for reconstructing the equation of the aspherical surface of mirrors in an explicit form using a device with a wavefront sensor [11487-9]
11487 0D	The optical system development and alignment for the Korsch type telescope [11487-11]
11487 OE	Implementation of a laser-truss based telescope metrology system at the Large Binocular Telescope [11487-58]
	OFFICAL TESTING / INTERFEROMETRY
11487 01	Interferometric measurement with robot kinematics [11487-15]
11487 OJ	Solutions for environmentally robust interferometric optical testing [11487-16]
	OPTICAL TESTING / DEFLECTOMETRY

11487 0K Aberration-induced errors in deflectometric measurement [11487-17]

11487 OL	Non-planar illumination sources for deflectometry [11487-18]
11487 OM	In-process metrology for segmented optics UV curing control [11487-19]
11487 ON	Full-aperture optical metrology for inflatable membrane mirrors [11487-20]
11487 00	Computational alignment of on-machine deflectometry [11487-57]

OPTICAL SYSTEM AND ALIGNMENT

11487 OT	Predictive Thermal Control (PTC) technology to enable thermally stable telescopes: year three
	status [11487-25]

- 11487 0U **Precision cementing of doublets without using a rotary table** [11487-26]
- 11487 0V Alignment of Multi-Order Diffractive Engineered (MODE) lens segments using the Kinematically-Engaged Yoke System [11487-27]
- 11487 OW Hyperion: Far-UV cross dispersion spectroscope design [11487-28]
- 11487 0X Precision space freeform optics for Microcarb: final report [11487-29]
- 11487 0Y A catalog approach to mounting optics for space applications [11487-56]

POLYMER OPTICS AND MOLDED GLASS OPTICS I

- 11487 0Z Precision glass molding of infrared optics with anti-reflective microstructures [11487-30]
- 11487 10 **Process evaluation and optimization for freeform precision glass molding** [11487-31]

POLYMER OPTICS AND MOLDED GLASS OPTICS II

- 11487 15 Distinguishing characteristics of diffractive optical elements and Fresnel lenses [11487-36]
- 11487 16 Foundry produced SU-8 inverted-rib waveguide-based components [11487-37]

OPTICAL MANUFACTURING II

11487 18 Fabrication and characterization of diffracto-freeform optics [11487-39]

OPTICAL CHARACTERIZATION

- 11487 1FAbsolute characterization of gravity sag [11487-46]
- 11487 1G A coronagraph for the sensing of fabrication errors in diffraction gratings [11487-47]
- 11487 1H Innovative test method for validating image quality performance of automotive lenses over operating temperature range [11487-48]

POSTER SESSION

- 11487 1L Hybrid-process-chain for polishing optical glass lenses HyoptO [11487-52]
- 11487 10 Measurement of retardance variations over the apertures of liquid-crystal variable retarders [11487-55]